

**CERTIFICATE OF ELECTRONIC
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I hereby certify that this correspondence for Application No. 10/524,525 is being electronically transmitted to Technology Center 1765, via EFS-WEB, on January 28, 2008.

/David H. Brinkman/ 1/28/08
David H. Brinkman, Reg. No. 40,532 Date

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Martin Hausner
Serial No.: 10/524,525
Filed: August 18, 2005
Confirmation No.: 1134
Group Art Unit: 1792
Examiner: Ahmed, Shamim
Title: **METHOD FOR SELECTIVELY REMOVING MATERIAL FROM
THE SURFACE OF A SUBSTRATE, MASKING MATERIAL FOR
A WAFER, AND WAFER WITH MASKING MATERIAL**
Atty. Docket: BEET-09

Cincinnati, Ohio 45202

January 28, 2008

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

SUPPLEMENTAL AFTER FINAL AMENDMENT

In response to the Final Office Action mailed on September 26, 2007, and supplementing the After Final Response filed on December 26, 2007, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 11 of this paper.